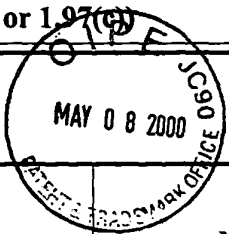


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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. SEC.506 #6/205	
In Re Application Of: Byong-taek LEE et al.				
Serial No. 09/276,803	Filing Date March 26, 1999	Examiner Not Assigned	Group Art Unit 2812	
Title: METHOD FOR MANUFACTURING CAPACITOR OF SEMICONDUCTOR DEVICE HAVING LAYER OF HIGH DIELECTRIC CONSTANT				
Address to: Assistant Commissioner for Patents Washington, D.C. 20231				
37 CFR 1.97(b)				
1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application; within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or before the mailing date of a first Office Action on the merits, whichever event occurs last.				
37 CFR 1.97(c)				
2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after three months of the filing of a national application, or the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or after the mailing date of a first Office Action on the merits, whichever occurred last but before the mailing date of either:				
1. a Final Action under 37 CFR 1.113, or				
2. a Notice of Allowance under 37 CFR 1.311,				
whichever occurs first.				
Also submitted herewith is:				
<input type="checkbox"/> a certification as specified in 37 CFR 1.97(e);				
OR				
<input type="checkbox"/> the fee set forth in 37 CFR 1.17(p) for submission of an Information Disclosure Statement under 37 CFR 1.97(c).				



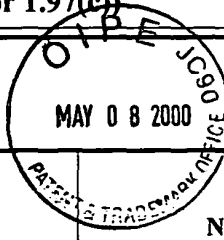
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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
SEC.506

In Re Application Of: **Byong-taek LEE et al.**



Serial No.
09/276,803

Filing Date
March 26, 1999

Examiner
Not Assigned

Group Art Unit
2812

Title: **METHOD FOR MANUFACTURING CAPACITOR OF SEMICONDUCTOR DEVICE HAVING LAYER OF HIGH DIELECTRIC CONSTANT**

Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of _____ is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 50-0238 as described below. A duplicate copy of this sheet is enclosed.
- ☐ Charge the amount of _____
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I certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. _____) on _____
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I certify that this document and fee is being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

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*This certificate may only be used if paying by deposit account.

Signature

Dated: MAY 8, 2000

BRIAN C. ALTMILLER
REG. NO. 37,271

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